Quantum SI Traceable Measurements and Calibrations: Radio Frequency Electric Fields and Power

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## Outline

 Rydberg atom-based SI traceable measurements for electric fields



 Rydberg atom-based SI traceable measurements for power

• Other applications







64 QAM





## **Re-definition of the SI in 2018**



The world of measurement science changed with the SI redefinition that occurred in November 2018.

As a result of the shift towards fundamental physical constants, we can rethink about how SI traceable measurements and calibrations are done.

Hence, we are developing fundamentally new methods for SI traceable measurement techniques for *E*-*field* and *RF power* (defined as 100's MHz to just below THz).





#### **Electric Field Measurements**





#### What are We Trying to Solve: Calibrating an E-field Probe



# Somewhat of a "Chicken-or-Egg" dilemma

To calibrate a probe, one must place the probe (sensor) in a "known" field.

However, to know the field we need a calibrated probe.





#### **E-field Probe**



#### **Limitations:**

- Field-levels: about 100 mV/m
- Requires calibration
- Perturbs the field (due to metal)
- Relatively large in size

#### To calibrate the probe, we need a "known" field.





## What are We Trying to Solve: Generating a Known Field

#### Horn antenna in an anechoic chamber

#### TEM cell

At the 2015 EMC Europe conference probe manufacturers stated that their probes only allow them to measure fields no better than 10 %.

**<u>0.5 dB (or 5%) accuracy</u>** 



#### GTEM cell





can We Do BE



## **Rydberg Atom Based Technique**



Rydberg atoms are atoms with one electron excited to a very high principal quantum number *n*, *i.e.*, *r*<sub>n</sub> *is very large*.

> Rydberg states have very large dipole moments: Meaning they are very sensitive to RF E-fields (making for good RF E-field sensors).

We us electromagnetically induced transparency (EIT) for the E-field sensing, either on resonance (Autler-Townes (AT) splitting) or off resonance (AC Stark shifts).

E 0.5

0.25

-25 -20 -15 -10



# Autler-Townes (AT) splitting

-5 0 5

 $\Delta p/2\pi$  (MHz

 $|E| = \Delta f \frac{\hbar}{\wp}$ 

10 15 20 25



AC Stark shifts







## **Rydberg Atom Based Technique: Purpose**

- Develop an SI traceable microwave *Electric-field* measurement technique.
- Develop an SI traceable microwave Power.
- Implement in a compact SI traceable probe
- •Useful as...
  - -Stand alone probe usable for test and measurement
  - -Calibration of existing probes
  - -Calibration of existing test facilities
  - -Calibration of existing power heads
  - -Other Applications





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## **IMPACT by NIST: Historical Perspective - eight years of effort**

2010: NIST wrote paper discussing using Rydberg atoms for SI measurements of electric fields

2011: DARPA funded to two groups on atom-based electric field sensors:

one lead from the University of Oklahoma: Sedlacek et al., 2012

one lead from of NIST: Holloway et al. 2014

2014-Present: Great Pi National Metrology Institutes, private companies, universities, and other government orld. Iaboratories) have started programs in the area of Rydberg atom-based sensors.

Including: USA, Germany, UK, Canada, China, Japan, South Korea, India, New Zealand, etc..

Gov. Labs: NIST, DOD, DOE, National Institute of Metrology (China), NPL (UK), etc..

Universities: U of Michigan, U of Oklahoma, U of Stuttgart, Durham Univ., U of Colorado, U of Maryland, Shanxi University, U College London, U of Ele. Science and Technology, U of Otago, U of Chinese Academy Sciences, Chongqing University, Institute of Laser Spectroscopy, Jiliang University, Jiliang University, Shandong University of Science and Technology, Pusan National University, Beijing Institute of Technology, etc.....

Several private companies: Rydberg Technologies, MITRE, SRI, other that I cannot mention, etc.....





#### Electromagnetic Induced Transparency (EIT) for SI Traceable M



rements

#### **EIT: Room Temperature Measurement**







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#### **Typical Experiment Result for the EIT Signal**







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## **Fiber-Coupled Probe: Moving Probe OFF Optical Table**







## **IMPACT by NIST: Historical Perspective - eight years of effort**

Amplitude: Most of this work was toward amplitude of the E-field: [NIST and a few others].

Polarization: [Sedlacek et al., APL, 2013].

The missing link was "phase" !

Phase: NIST-[Simons et al., APL, 2019].

We can now <u>fully characterize</u> a radio frequency field, in that the amplitude, phase, and polarization of the field can be determined in one compact quantum-based sensor.

We can now start looking at a wide array of applications.





#### **Rydberg Atom Mixer: Measuring Phase**



**CW carrier: Phase Shift** 





#### **Rydberg Atom Mixer: Phase Modulation for Communications**



#### What Else Can We DO: Quantum-Physics-Meets-Music



## **AM/FM Stereo Reception**



## **Other Applications**

- Atom-based receivers/antennas
- Quantum RF imaging and visualization technology (RF camera)
- Quantum-enabled medical imaging and diagnostics
- Plasma sensors
- Atomic DC/AC voltage and current references
- Atomic thermal field sensing and measurement (blackbody radiation calibrations)
- Single microwave photon detection
- Quantum storage of radio frequency, microwave, and THz photons using slow light effects in Rydberg gases. (Quantum encrypted Rydberg atom quantum receivers from 1 GHz to 1 THz)
- Waveguide Power Measurements: Power Calibrations
- Sub-wavelength imaging
- Near-field imaging
- Measuring Noise sources







## **RF Atomic-Vapor-Cell (AVC) Camera**



## Traceable Reference Fields for mmWave Wireless: Calibrated Facilities



#### **SI Traceable Power**

#### We now have a SI traceable E-field measurement.

#### What else can we do?

**NEW Atom-Based SI traceable Power Measurements.** 







#### **SI Traceable Power**

TE<sub>10</sub> mode in rectangular waveguide only allowed mode at measurement frequency  $\vec{E} = E_0 \sin \frac{\pi x}{a} \left\{ e^{-j\beta z} + \Gamma e^{j\beta z} \right\} \hat{y}$ 

 $\frac{1}{2}$  sinusoid in x, constant in y, partial standing wave in z

**Transmitted Power** 

$$P_{trans} = E_0^2 \frac{ab}{4} \sqrt{\frac{\varepsilon_0}{\mu_0}} \sqrt{1 - \left(\frac{c}{2af}\right)^2}$$

Depends on *E*, physical constants ( $\varepsilon_0$ ,  $\mu_0$ , *c*), and geometry (*a*,*b*)

We measure E with the Rydberg atoms and power is traceable to Planck's constant.







#### **SI Traceable Power**



**Transmitted Power** 

$$P_{trans} = E_0^2 \frac{ab}{4} \sqrt{\frac{\varepsilon_0}{\mu_0}} \sqrt{1 - \left(\frac{c}{2af}\right)^2}$$







#### SI Traceable Power: New Paradigm--Calibrated Source

cell







## Summary

#### **Fundamentally new approach for E-field and Power measurements**

#### **E-Fields**

•Broadband probe/sensor: 10 MHz-to-500 GHz (possibly to 1 THz)

•Will allow direct SI units linked RF electric field (E-field) measurements

•Would provide RF field measurements independent of current techniques

•Very small and compact probe: fiber-coupled atom-based probe

•Measure *weak* and *large* E-field strengths over a large range of frequencies :  $< 1 \mu V/m$  and > 10 kV/m:

#### **POWER**

•SI traceable Power measurements

•Calibrations above 110 GHz

•Real-time power calibrations





The bottom line is that we would be developing a measurement technique that could be applied to various form factors and applications.

## **Journal Publications on Rydberg Atom Sensors**

- 1. Holloway, et al., "Sub-Wavelength Imaging and Field Mapping via electromagnetically induced transparency and Autler-Townes Splitting In Rydberg Atoms," *Applied Physics Letters*, vol.1 104, 244102, 2014.
- 2. Holloway, et al., "Broadband Rydberg Atom-Based Electric-Field Probe/Sensor: From Self-Calibrated Measurements to Sub-Wavelength Imaging," *IEEE Trans. on Antenna and Propagation*, vol. 62, no. 12, 6169-6182, 2014.
- 3. Gordon, et al., "Millimeter-Wave Detection via Autler-Townes Splitting In Rubidium Rydberg Atoms", Applied Physics Letters, vol. 105, 024104, 2014.
- 4. Anderson, et al., "Two-photon transitions and strong-field effects in Rydberg atoms via EIT-AT," Applied Physics Review, vol. 90, 043419, 2014.
- 5. Fun et al. "Effect of Vapor Cell Geometry on Rydberg Atom-based Radio-frequency Electric Field Measurements", *Physical Review Applied*, vol. 4, 044015, 2015.
- 6. Anderson et al., "Optical measurements of strong microwave fields with Rydberg atoms in a vapor cell", *Physical Review Applied*, 5, 034003, 2016.
- 7. Simons et al., "Using frequency detuning to improve the sensitivity of electric field measurements via electromagnetically induced transparency and Autler-Townes splitting in Rydberg atoms", *Applied Physics Letters*, 108 174101, 2016.
- 8. Simons, et al. "Simultaneous use of Cs and Rb Rydberg atoms for dipole moment assessment and RF electric field measurements via electromagnetically induced transparency", J. Appl. Phys., 102, 123103, 2016.
- 9. Holloway, et al., "Atom-Based RF Electric Field Metrology: From Self-Calibrated Measurements to Sub-Wavelength and Near-Field Imaging", *IEEE Trans. on Electromagnetic Compat., Special Issue of Near-Field Imaging*, vol. 59, no. 2, pp. 717-728, April 2017.
- 10. Holloway, et al., "Electrical Field Metrology for a New SI: A Study of Systematic Measurement Uncertainties in Electromagnetically Induced Transparency in Atomic Vapor", J. of Applied Physics, May, 2017.
- 11. Anderson, et al., "Optical measurements of plasma fields using Rydberg atoms on electromagnetically induced transparency", J. of Applied Phys, 2018.
- 12.Simons, et al., "Electromagnetically Induced Transparency (EIT) and Autler-Townes (AT) splitting in the Presence of Band-Limited White Gaussian Noise", J. of Applied Physics, vol. 123, 203105, 2018.
- 13.Holloway, et al., "A New Quantum-Based Power Standard: Using Rydberg Atoms for a SI-Traceable Radio-Frequency Power Measurement Technique in Rectangular Waveguides", *Applied Phys. Letters*, vol. 113, 094101, 2018.
- 14. Simons, et al., "Fiber-coupled vapor cell for a Rydberg atom-based electric field sensor", Applied Optics, vol. 57, no. 22, pp. 6456-6460, 2018.
- 15. Simons, et al, "A Rydberg Atom-Based Mixer: Measuring the Phase of a Radio Frequency Wave," Applied Physics Letters, vol. 114, 114101, 2019.
- 16.Gordon, et al., "Weak Electric-Field Detection with Sub-1 Hz Resolution at Radio Frequencies Using a Rydberg Atom-Based Mixer, *AIP Advanced*, vol. 9, 045030, 2019.
- 17.Holloway, et al. "Quantum Physics Meets Music: A ``Real-Time" Guitar Recording Using Rydberg-Atoms and Electromagnetically Induced Transparency," *AIP Advanced*, vol. 9, 065110, 2019.

- 1. Gordon, et al, "Quantum-Based SI Traceable Electric-Field Probe," Proc of 2010 IEEE International Symposium on Electromagnetic Compatibility, July 25-30, 321-324, July 2010.
- 2. Holloway, et al., "Broadband Rydberg Atom Based Self-Calibrating RF E-Field Probe", 2014 XXXIth URSI General Assembly and Scientific Symp., Beijing, China, Aug, 2014.
- 3. Holloway, et al., "Atom-Based RF Electric Field Measurements: An Initial Investigation of the Measurement Uncertainties", *EMC 2015: Joint IEEE International Symposium on Electromagnetic Compatibility and EMC Europe*, Dresden, Germany, pp. 467-472, 2015.
- 4. Holloway, et al., "Atom-Based RF Field Probe: From Self-Calibrated Measurements to Sub-Wavelength Imaging", *IEEE NANO 2015: 15th International Conference on Nanotechnology*, Rome, Italy, 2015.
- 5. Simons, et al., "Atom-based RF electric field metrology above 100 GHz", SPIE: Terahertz, RF, Millimeter, and Submillimeter-Wave Technology and Applications, Feb, 2016.
- 6. Holloway, et al., "Using Cs and Rb Rydberg Atoms Simultaneously for SI-Traceable RF Electric-Field Metrology via Electromagnetically Induced Transparency", *EMC Europe 2016*, Aug. 2016.
- 7. Holloway, et al., "Development of A New Atom-Based SI Traceable Electric-Field Metrology Technique", AMTA, 2017.
- 8. Holloway, et al., "Development and Applications of a Fiber-Coupled Atom-Based Electric Field Probe", EMC Europe 2018, Amsterdam, NL, Aug. 2018.
- 9. Simons, et al., "An investigation of the uncertainties in the EIT/AT based approach for E-field metrology", EMC Europe 2018, Amsterdam, NL, Aug. 2018.
- 10.Anderson, et al., "High-resolution antenna near-field imaging and sub-THz measurements with a small atomic vapor-cell sensing element", *GSMM18*, Boulder, Co, 2018.

#### ??Questions??











